

ENTRY NO. C7 Date June 20/92
 Name of Machine HIRFL Sector Focusing Cyclotron (Injector)
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HISTORY
 MILESTONE DATES:
 Design Model Tests
 Construction First Beam
 DESIGN/CONSTRUCTION BY:
 in house other
 COST: Accelerator Facility
 FUNDED BY:

STATUS
 STAFF: Machine
 Scientists 10 Engineers 10
 Technicians 10 Students 3
 Research (in house/external)
 Scientists / Engineers /
 Technicians / Students /
 BUDGET: Machine Funded by
 Research Funded by
 TIME DISTRIBUTION:
 Basic Research (in house/external) % / %
 Applied Program (in house/external) % / %
 Development % Maintenance %

MAGNET
 POLE PARAMETERS:
 Diameter 170 cm $R_{extract}$ 75 cm R_{inject} 4.5 cm
 HILL PARAMETERS: Gap (min) 19 cm B_{max} 2.0 T
 (Θ AT) Gap (max) cm B_{min} T
 VALLEY PARAMETERS: Gap (min) cm B_{max} T
 (Θ AT) Gap (max) 31.6 cm B_{min} 1.2 T
 AVERAGE FIELD: $\langle B \rangle_{min}$ 0.8 T $\langle B \rangle_{max}$ 1.6 T
 NUMBER OF SECTORS: compact/separated 3 /
 sector angle deg. spiral (max) 33 deg.
 FIELD TRIMMING: Trim Coils 12
 Harmonic Coils 4 X 3
 Other
 CURRENT: Main Coils 1300 Amps Stability 1×10^{-5}
 Trim Coils 500 Amps Stability 1×10^{-4}
 Stored Energy (cryogenic) MJ
 WEIGHT: Iron 220 tons Conductor 16 tons
 ION ENERGY: Bending Limit $E/A = 69 \text{ q}^2/A^2 \text{ MeV/u}$
 Focussing Limit $E/A = \text{q/A MeV/u}$

ACCELERATION SYSTEM
 FUNDAMENTAL ACCELERATION:
 Description: 1/2 lambda/1 resonator
 No. of Gaps/turn 2 $dE/dn(max)$ 0.2 MeV/q
 Voltage(max) 100 MV Harmonic f_{rf}/f_{ion} 1, 3
 Freq 18 MHz Power in(max) 0.2 MW
 Stability: Phase 1 deg Voltage 10^{-3} MW
 OTHER CAVITIES (Flattopping or otherwise):
 Description:
 Region of Influence: R_{min} cm R_{max} cm
 No. of Gaps/turn $dE/dn(max)$ MeV/q
 Voltage(max) MV Harmonic f_{rf}/f_{ion}
 Freq MHz Power in(max) MW
 Stability: Phase Voltage

VACUUM SYSTEM
 OPERATING PRESSURE: 5×10^{-5} Pa
 PUMPS: No. and type 2 HIRFL 800 cryo-pumps,
 2 turbo-pumps, rough pumping system

ION SOURCE(S)
 Type Intensity (mA) Θ $\epsilon_n = \beta\gamma\epsilon$ (mm mrad) Ion Species
 (a) ECR 0.1-0.3 200 C - Ta
 (b)
 (c)
 (d)

INJECTION SYSTEM
 spiral electrostatic inflector Efficiency 30 %

EXTRACTION SYSTEM
 electrostatic deflectors + magnetic channel Efficiency 70 %

CHARACTERISTIC BEAMS
 Accelerated Ions E/A (MeV/u) Current(part μA)
 Internal External
 (a) C^{4+} 4.5 1
 (b) C^{4+} 6.6 1
 (c) O^{5+} 4.5 1
 (d) Ar^{8+} 2.3 0.8
 Secondary Particles E (MeV) part/sec
 (a)
 (b)
 (c)

EXTRACTED BEAM PROPERTIES:
 For μA of MeV/u ions
 $\Delta E/E$ % $\Delta\phi$ deg
 $\epsilon_n = \beta\gamma\epsilon$ x mm mrad z mm mrad

FACILITIES FOR RESEARCH
 SHIELDED AREA: Fixed m² Moveable m²
 Target Stations: No. Served At Same Time:
 MAGNETIC SPECTROMETERS:
 OTHER FACILITIES:

REFERENCES/NOTES
 (a)
 (b)

PLAN VIEW OF FACILITY, COMMENTS

